

Docket No. \_\_\_\_\_

**COMBINED DECLARATION/POWER OF ATTORNEY**  
**FOR PATENT APPLICATION**

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name.

I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled

**PRODUCTION METHOD OF SEMICONDUCTOR DEVICE**

\_\_\_\_\_, the specification of which

(check one)        X   is attached hereto.

\_\_\_\_\_ was filed on \_\_\_\_\_ as  
Application Serial No. \_\_\_\_\_.

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by any amendment referred to above.

I acknowledge the duty to disclose information which is material to the examination of this application in accordance with Title 37, Code of Federal Regulations, § 1.56(a).

I hereby claim foreign priority benefits under Title 35, United States Code, § 119 of any foreign application(s) for patent or inventor's certificate listed below and have also identified below any foreign application for patent or inventor's certificate having a filing date before that of the application on which priority is claimed:

Prior Foreign Application(s)			Priority Claimed
<u>2002-245509</u> (Number)	<u>JAPAN</u> (Country)	<u>26/08/2002</u> (Day/Month/Year Filed)	<u>  X  </u> Yes <u>  </u> No
_____ (Number)	_____ (Country)	_____ (Day/Month/Year Filed)	<u>  </u> Yes <u>  </u> No
_____ (Number)	_____ (Country)	_____ (Day/Month/Year Filed)	<u>  </u> Yes <u>  </u> No

I hereby claim the benefit under Title 35, United States Code, § 120 of any United States application(s) listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States application in the manner provided by the first paragraph of Title 35, United States Code, § 112, I acknowledge the duty to disclose material information as defined in Title 37, Code of Federal Regulations, § 1.56(a) which occurred between the filing date of the prior application and the national or PCT international filing date of this application:

Full name of second inventor Takeshi HARADA

Inventor's signature Takeshi Harada Date August 8, 2003

Residence\* Shiga, Japan Citizenship Japan

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Full name of third inventor Kazushi NII

Inventor's signature Kazushi Nii Date August 8, 2003

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Full name of forth inventor Takenobu KISHIDA

Inventor's signature Takenobu Kishida Date August 8, 2003

Residence\* Osaka, Japan Citizenship Japan

Post Office Address 1-20-10-603, Senrioka-higashi, Settsu-shi, Osaka 566-0011, Japan

Full name of fifth inventor Atsushi IKEDA

Inventor's signature Atsushi Ikeda Date August 8, 2003

Residence\* Niigata, Japan Citizenship Japan

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Full name of sixth inventor Kazunori TSUJI

Inventor's signature Kazunori Tsuji Date August 8, 2003

Residence\* Kyoto, Japan Citizenship Japan

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\* City and State, or City and Country for foreign inventors

Docket No.: 60188-635

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
	:	
Shuji HIRAO, et al.	:	Confirmation Number:
	:	
Serial No.:	:	Group Art Unit:
	:	
Filed: August 20, 2003	:	Examiner:
	:	
For:		PRODUCTION METHOD OF SEMICONDUCTOR DEVICE

**ASSOCIATE POWER OF ATTORNEY**

Mail Stop  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

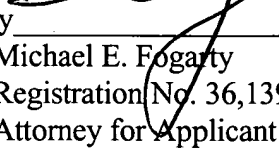
The undersigned Principal Attorney of record hereby appoints the following Attorneys as his Associates with regard to the above-identified application: Steven W. Allis, Reg. No. 50,532; Stephen A. Becker, Reg. No. 26,527; John G. Bisbikis, Reg. No. 37,095; Daniel Bucca, Reg. No. 42,368; Kenneth L. Cage, Reg. No. 26,151; Jennifer Chen, Reg. No. 42,404; Bernard P. Codd, Reg. No. 46,429; Lawrence T. Cullen, Reg. No. 44,489; Paul Devinsky, Reg. No. 28,553; Margaret M. Duncan, Reg. No. 30,879; Shamita De. Etienne-Cummings, Reg. No. 46,072; Ramyar M. Farid, Reg. No. 46,692; Brian E. Ferguson, Reg. No. 36,801; Michael E. Fogarty, Reg. No. 36,139; John R. Fuisz, Reg. No. 37,327; Keith E. George, Reg. No. 34,111; John A. Hankins, Reg. No. 32,029; Eric J. Kraus, Reg. No. 36,190; Catherine Krupka, Reg. No. 46,227; Jack Q. Lever, Reg. No. 28,149; Raphael V. Lupo, Reg. No. 28,363; Burman Y. Mathis III, Reg. No. 44,907; Michael A. Messina, Reg. No. 33,424; Dawn L. Palmer, Reg. No. 41,238; Joseph H. Paquin, Jr., Reg. No. 31,647; Scott D. Paul, Reg. No. 42,984; William D. Pegg, Reg. No. 42,988; Robert L. Price, Reg. No. 22,685; Gene Z. Robinson, Reg. No. 33,351; Brian K. Seidleck, Reg. No. 51,321; Joy Ann G. Serauskas, Reg. No. 27,952; Jiri F. Smetana, Reg. No. 52,456; David A. Spenard, Reg. No. 37,449; Arthur J. Steiner, Reg. No. 26,106; Michael D. Switzer, Reg. No. 39,552; David M. Tennant, Reg. No. 48,362; Judith L. Toffenetti, Reg. No. 39,048; Daniel S. Trainor, Reg. No. 43,959; Shival P. Virmani, Reg. No. 45,032; Kelli N. Watson, Reg. No. 47,170; Cameron K. Weiffenbach, Reg. No. 44,488; Aaron Weisstuch, Reg. No. 41,557; Edward

**Serial No.:**

J. Wise, Reg. No. 34,523; Jeffrey A. Woller, Reg. No. 48,041; Alexander V. Yampolsky, Reg. No. 36,324; Robert W. Zelnick, Reg. No. 36,976; and Wei-Chen Chen, admitted under 37 CFR 10.9(b) all of

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Please continue to address all communications to the undersigned.  
Michael E. Fogarty  
August 20, 2003

By   
\_\_\_\_\_  
Michael E. Fogarty  
Registration No. 36,139  
Attorney for Applicant